

Notice of References Cited		Application/Control No. 10/760,281	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
		Examiner Adam C. Rehm	Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-2005/0128767	06-2005	Wang et al.	362/555
B	US-2004/0052076	03-2004	Mueller et al.	362/293
C	US-			
D	US-			
E	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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